



Attorney Docket SEL 203

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re Application of)
)
NAKAJIMA et al.)
)
Serial No.: 09/635,945)
)
Filed: August 10, 2000)
)
For: Semiconductor Device And Method)
Of Manufacturing The)
Semiconductor Device)
)
Art Unit: 2811)
)
Examiner: S. Hu)

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February 10, 2004

(Date of Deposit)

Shannon Wallace

Name of applicant, assignee, or Registered Rep

Shannon Wallace 2/10/04

Signature

Date

Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT E (AFTER FINAL)

In response to the Final Rejection of October 10, 2003, a one month extension of time being submitted herewith, please amend the above-identified application as follows:

02/26/2004 JMC/HILL 00000005 501039 09635945

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86.60 DA